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By: *Linda E. Hastings*  
LINDA E. HASTINGS

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Attorney Docket No.: NECK 17.552

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor: Hiroshi TANABE  
Serial No.: 09/614,286  
Filed: July 12, 2000  
Title: **METHOD FOR FORMING SEMICONDUCTOR FILMS  
AT DESIRED POSITIONS ON A SUBSTRATE**  
Examiner: Timothy J. Sutton  
Group Art Unit: 2813

Assistant Commissioner for Patents  
Washington, D.C. 20231

**ELECTION**

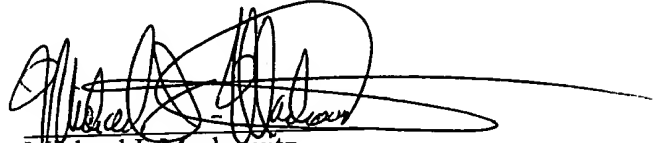
SIR :

In response to the Office Action mailed on September 10, 2001, the period for responding thereto having been set to expire after October 10, 2001, Applicant hereby elects Group I, claims 1-10, for prosecution at this time. Applicant reserves the right to file a continuing application based on claims 11-14. Early examination on the merits is earnestly solicited.

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Respectfully submitted,

A handwritten signature in black ink, appearing to read 'Michael I. Markowitz', with a long horizontal flourish extending to the right.

Michael I. Markowitz  
Reg. No. 30,659

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